



AF #

PATENT

Customer No. 22,852

Attorney Docket No. 7553.0008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Chishio KOSHIMIZU et al.)

Application No: 09/665,940)

Filed: September 21, 2000)

For: PLASMA PROCESSING)
APPARATUS AND PLASMA)
PROCESSING METHOD)

) Group Art Unit: 1765 ✓

) Examiner: L. UMEZ ERONINI

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

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PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office

Action of August 27, 2003. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: 

Michael W. Kim
Reg. No. 51,880

Dated: December 4, 2003

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